



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
KALAS et al.

Serial No: 09/880,190

Filed: June 12, 2001

For: THIN RADIATION SOURCE AND
METHOD OF MAKING THE SAME

) Art Unit: 2881
Examiner: GURZO, PAUL M.

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action dated June 18, 2003 in connection with the
above-identified application, please enter and consider the following amendment and
remarks.

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